



JUN 13 2005

AMENDMENT TRANSMITTAL LETTER

Docket No.
SON-1718

Application No. 09/478,812-Conf. #2204	Filing Date January 7, 2000	Examiner E. Lee	Art Unit 2815
---	--------------------------------	--------------------	------------------

Applicant(s): Yasukiyasu Sugano et al.

Invention: PROCESS FOR PRODUCING THIN FILM SEMICONDUCTOR DEVICE AND LASER
IRRADIATION APPARATUS

TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	14	- 74 =		x	0.00
Independent Claims	14	- 31 =		x	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify): Extension for response within third month					1,020.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					1,020.00

 Large Entity Small Entity No additional fee is required for this amendment. Please charge Deposit Account No. 18-0013 in the amount of \$ 1,020.00
A duplicate copy of this sheet is enclosed. A check in the amount of \$ _____ to cover the filing fee is enclosed. Payment by credit card. Form PTO-2038 is attached. The Director is hereby authorized to charge and credit Deposit Account No. 18-0013
as described below. A duplicate copy of this sheet is enclosed. Credit any overpayment. Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

Dated: June 13, 2005

Ronald P. Kananen
Attorney Reg. No.: 24,104RADER, FISHMAN & GRAUER PLLC
1233 20th Street, N.W.
Suite 501
Washington, DC 20036
(202) 955-3750

DC197352



Docket No.: SON-1718
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yasukiyasu Sugano et al.

Confirmation No. 2204

Application No.: 09/478,812

Art Unit: 2815

Filed: January 7, 2000

Examiner: E. Lee

For: **PROCESS FOR PRODUCING THIN FILM
SEMICONDUCTOR DEVICE AND LASER
IRRADIATION APPARATUS**

AMENDMENT RESPONSIVE TO ACTION OF DECEMBER 13, 2005

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In full and timely response to the Action of December 13, 2004, please further amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.